

slotted configuration of the waveguide/antenna structure makes the device scalable to larger areas and higher powers. All that is needed for scaling up is the attachment of additional matched radiating slots along the length of the discharge chamber. If it is desired to make the power per slot remain constant in scaling up, then the input microwave power must be increased accordingly.

Unlike in prior ECR microwave plasma-generating devices, there is no need for an insulating window on the

antenna. Such windows are sources of contamination and gradually become ineffective as they become coated with erosion products over time. These characteristics relegate prior ECR microwave plasma-generating devices to non-ion beam, non-deposition plasma applications. In contrast, the lack of need for an insulating window in the present device makes it possible to use the device in both ion-beam (including deposition) and electron-beam applications. The device is designed so that ECR takes place

above each slot and the gradient of the magnetic field at each slot is enough to prevent backflow of plasma.

This work was done by John E. Foster of Glenn Research Center. Further information is contained in a TSP (see page 1).

Inquiries concerning rights for the commercial use of this invention should be addressed to NASA Glenn Research Center, Commercial Technology Office, Attn: Steve Fedor, Mail Stop 4-8, 21000 Brookpark Road, Cleveland, Ohio 44135. Refer to LEW-17589-1.

Fiber-Optic Strain Gauge With High Resolution And Update Rate

Changes in strain are correlated with changes in speckle patterns.

Stennis Space Center, Mississippi

An improved fiber-optic strain gauge is capable of measuring strains in the approximate range of 0 to 50 microstrains with a resolution of 0.1 microstrain. (To some extent, the resolution of the strain gauge can be tailored and may be extensible to 0.01 microstrain.) The total cost of the hardware components of this strain gauge is less than \$100 at 2006 prices. In comparison with prior strain gauges capable of measurement of such low strains, this strain gauge is more accurate, more economical, and more robust, and it operates at a higher update rate. Strain gauges like this one are useful mainly for measuring small strains (including those associated with vibrations) in such structures as rocket test stands, buildings, oilrigs, bridges, and dams. The technology was inspired by the need to measure very small strains on structures supporting liquid oxygen tanks, as a way to measure accurately mass of liquid oxygen during rocket engine testing.

This improved fiber-optic strain gauge was developed to overcome some of the

deficiencies of both traditional foil strain gauges and prior fiber-optic strain gauges. Traditional foil strain gages do not have adequate signal-to-noise ratios at such small strains. Fiber-optic strain gauges have been shown to be potentially useful for measuring such small strains, but heretofore, the use of fiber-optic strain gauges has been inhibited, variously, by complexity, cost, or low update rate.

The improved fiber-optic strain gauge is partially composed of a multi-mode fiber optic which is wound in an elliptical pattern and bonded to the structure of interest. A laser is fixed within an adjustable cylindrical steel enclosure and aimed at one end of the optical fiber. The laser light emerging from the other end of the fiber forms a speckle pattern that changes as strain is applied to the structure. The speckle pattern is intercepted by an array of photocells, so that any change in the speckle pattern manifests itself in changes in the intensities of light measured by the individual photocells. The

outputs of the photocells are collected by a customized data-acquisition system that includes a signal-conditioning subsystem. The photocell outputs are then fed to a neural network that recognizes the correlation between changes in the outputs and changes in strain.

Inasmuch as the changes in the intensities of light incident on the photocells are repeatable for a given amount of change in strain, the neural network can be quickly trained by use of speckle patterns associated with known levels of strain. For measurement of temporally varying strain (for example, when vibrations are present), the update rate and, hence, the dynamic analysis rate depends on the data-acquisition rate.

This work was done by Fernando Figueroa of Stennis Space Center and Ajay Mahajan, Mohammad Sayeh, and Bradley Regez of Southern Illinois University, Carbondale.

Inquiries concerning rights for the commercial use of this invention should be addressed to Intellectual Property Manager, NASA Stennis Space Center; (228) 688-1929. Refer to SSC-00243.

Broadband Achromatic Telecentric Lens

Lens works with a matched spectrometer for applications covering the entire solar-reflected spectrum.

NASA's Jet Propulsion Laboratory, Pasadena, California

A new type of lens design features broadband achromatic performance as well as telecentricity, using a minimum number of spherical elements. With appropriate modifications, the lens design

form can be tailored to cover the range of response of the focal-plane array, from Si (400–1,000 nm) to InGaAs (400–1,700 or 2,100 nm) or InSb/HgCdTe reaching to 2,500 nm. For reference, lenses typically

are achromatized over the visible wavelength range of 480–650 nm.

In remote sensing applications, there is a need for broadband achromatic telescopes, normally satisfied with mirror-

based systems. However, mirror systems are not always feasible due to size or geometry restrictions. They also require expensive aspheric surfaces. Non-obsured mirror systems can be difficult to align and have a limited (essentially one-dimensional) field of view. Centrally obscured types have a two-dimensional but very limited field in addition to the obscuration. Telecentricity is a highly desirable property for matching typical spectrometer types, as well as for reducing the variation of the angle of incidence and cross-talk on the detector for simple camera types.

This rotationally symmetric telescope with no obscuration and using spherical surfaces and selected glass types fills a need in the range of short focal lengths. It can be used as a compact front unit for a matched spectrometer, as an ultra-broadband camera objective lens, or as the optics of an integrated camera/spectrometer in which the wavelength information is obtained by the use of strip or linear variable filters on the focal plane array. This kind of camera and spectrometer system can find applications in remote sensing, as well as *in-situ* applications for geologi-

cal mapping and characterization of minerals, ecological studies, and target detection and identification through spectral signatures. Commercially, the lens can be used in quality-control applications via spectral analysis.

The lens design is based on the rear landscape lens with the aperture stop in front of all elements. This allows sufficient room for telecentricity in addition to making the stop easily accessible. The crucial design features are the use of a doublet with an ultra-low dispersion glass (fluorite or S-FPL53), and the use of a strong negative element, which enables flat field and telecentricity in conjunction with the last (field lens) element. The field lens also can be designed to be in contact with the array, a feature that is desirable in some applications.

The lens has a 20° field of view, for a 50-mm focal length, and is corrected over the range of wavelengths of 450–2,300 nm. Transverse color, which is the most pernicious aberration for spectroscopic work, is controlled at the level of 1 μm or below at 0.7 μm field and 5 μm at full field. The maximum chief ray angle is less than 1.7°, provid-

ing good telecentricity. An additional feature of this lens is that it is made exclusively with glasses that provide good transmission up to 2,300 nm and even some transmission to 2,500 nm; thus, the lens can be used in applications that cover the entire solar-reflected spectrum. Alternative realizations are possible that provide enhanced resolution and even less transverse color over a narrower wavelength range.

This work was done by Pantazis Mouroulis of Caltech for NASA's Jet Propulsion Laboratory. Further information is contained in a TSP (see page 1).

In accordance with Public Law 96-517, the contractor has elected to retain title to this invention. Inquiries concerning rights for its commercial use should be addressed to:

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